

FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Docket Number (Optional) 89285.0007	Application Number 10/537,447
	Applicant IWASAKI, et al.	
	Filing Date March 21, 2006	Group Art Unit 3728

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EXAMINER	DATE CONSIDERED
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EXAMINER /Adam Krupicka/	DATE CONSIDERED 01/22/2009
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /A.K./